

APPLICATION NO.: 10/812,347  
Docket: ES-038 (071469-0307558)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:  
**HIGUCHI, Fumihiko et al.**

Confirmation Number: 2682

Application No.: **10/812,347**

Group Art Unit: 1792

Filed: March 30, 2004

Examiner: CHEN, Kin Chan

Title: PROCESSING SYSTEM AND METHOD FOR TREATING A SUBSTRATE

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated August 1, 2008, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.